

**Cathodic plasma / bare-tether contact through  
low Work function coating**

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**Bare (uninsulated) tethers eliminated need for electron collector at anodic end.**

**Convenience of using bare tethers with no recourse to a plasma contactor (hollow cathode) at cathodic end carries bare-tether concept to its full completion.**

**Ion collection along a cathodic segment is a poor replacement for a Hollow Cathode.**

**Thermionic electron emission from materials with low Work function  $W$  may be a good replacement.**

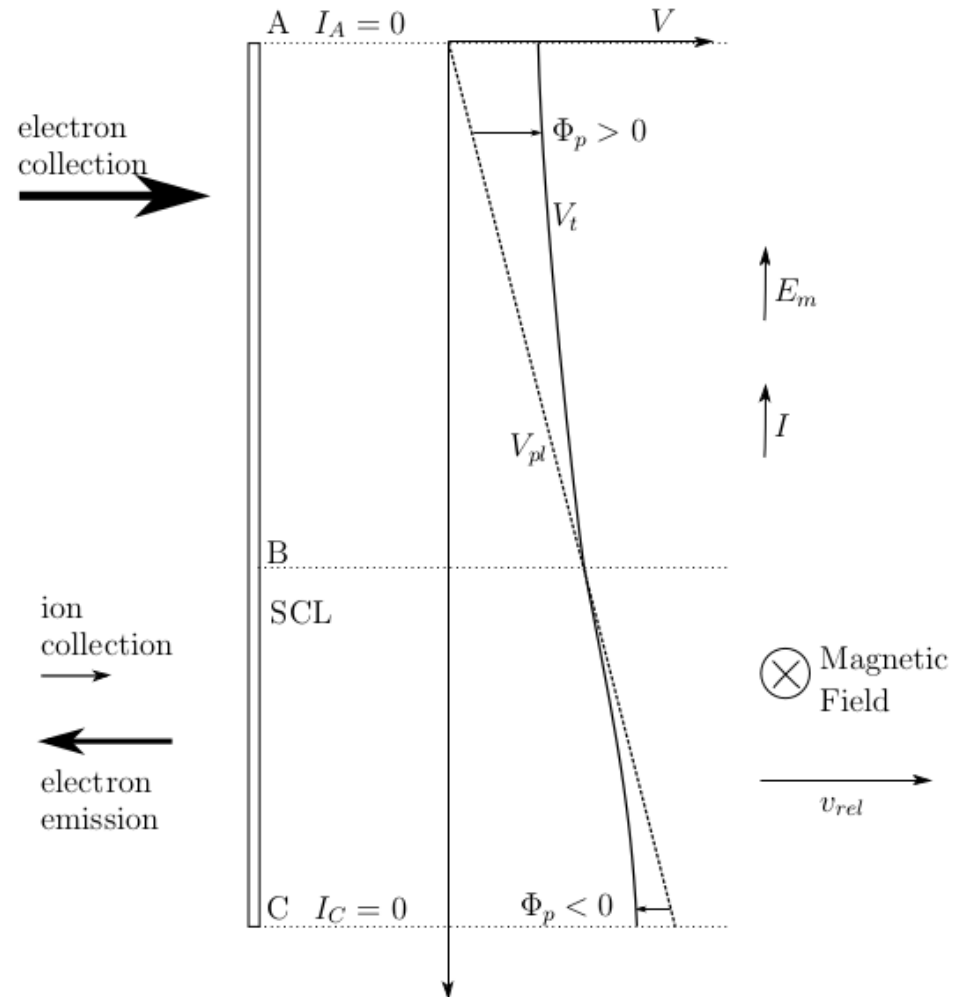
**A low Work function material, C12A7:e<sup>-</sup>, developed and studied at the University of Tokyo by the Prof. H. Hosono group, presents a potential value  $W = 0.6$  eV, at stable temperatures.**

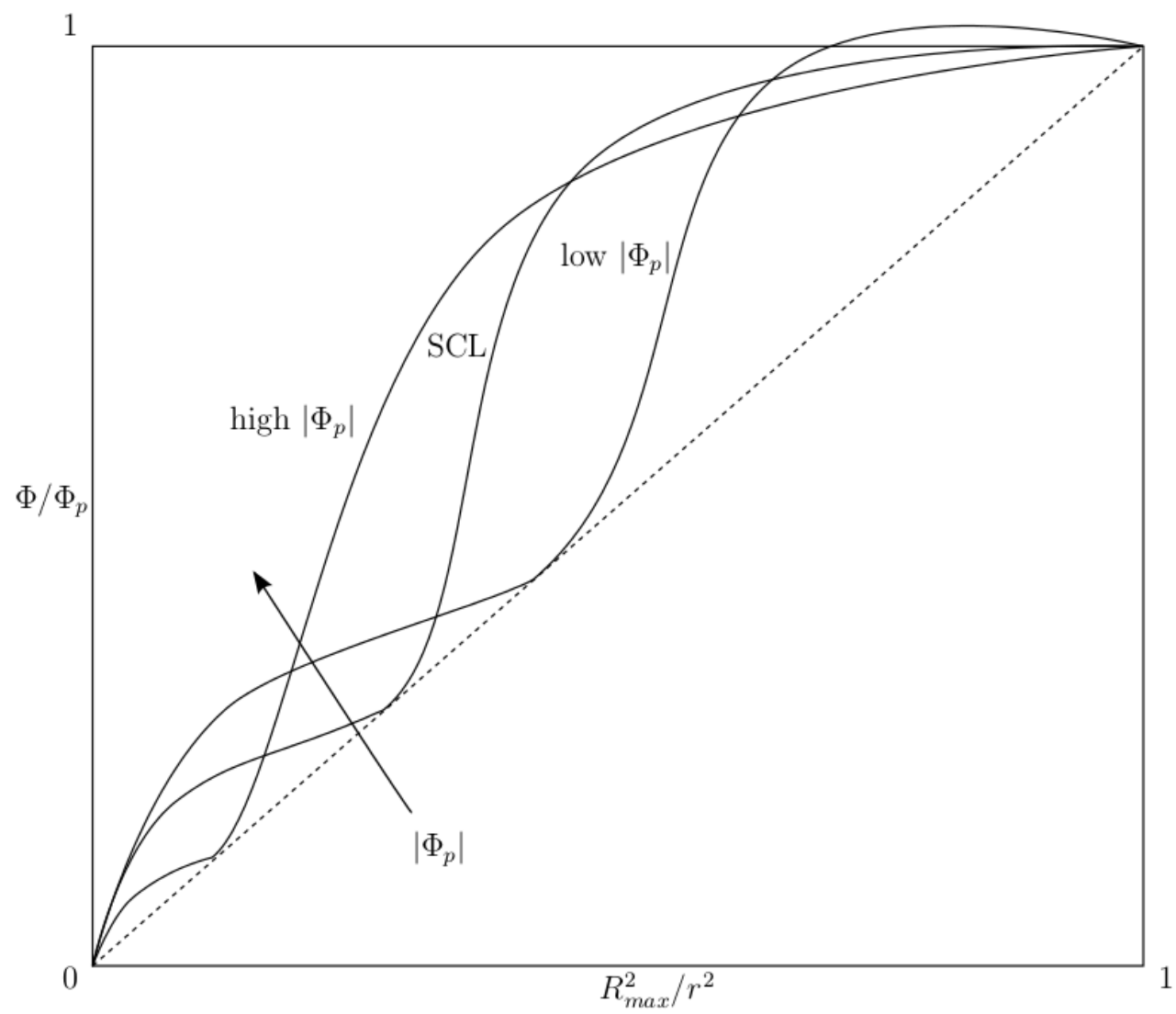
**This goes well beyond standard material values well over 2 eV.**

**Coating a tether with C12A7:e<sup>-</sup> would allow efficient thermionic emission, and so cathodic contact plasma/tether, at reasonable working temperatures.**

**Thermionic emission is different from hollow-cathode emission in important respects concerning a tether system:**

- a) Just electrons rather than plasma are emitted;**
- b) Cylindrical rather than spherical geometry is involved: the first geometry allows for OML current of attracted species, following an explicit law, the second one does not.**
- c) A single, definite physical (Richardson-Dushman) law for emission current is involved, which is not the case for a hollow cathode, for which broadly different regimes may exist, giving rise to quite different schemes/analyses;**
- d) Hollow cathode emission occurs at just a point in the tether, thermionic emission occurs over a long segment of tether under a range of voltage-bias values.**
- e) Use of laboratory tests results in designing HC for use in space is tricky.**





**Emitted electrons density negligible beyond the sheath; use results from (Phys. Plasmas, 6, 395, 1999). Use high-bias OML current, at  $R_{\max}$  for OML validity**

$$I_i = L \times 2 R_{\max} e N_{\infty} \sqrt{2e|\Phi_p|/m_i}$$

$$r_{sh} \approx r_2 \approx r_1 \approx R_{\max} \times \sqrt{\frac{1}{\sigma_1}} \times \sqrt{\frac{e|\Phi_p|}{kT}}, \quad \sigma_1 \approx 0.24 \quad \text{for } T_e = T_i \equiv T$$

$$\frac{N_i}{N_{\infty}} = \frac{\kappa}{\pi} \frac{R_{\max}}{r} \sqrt{\frac{\Phi_p}{\Phi}}, \quad \kappa(T_i/T_e = 1) \approx 3$$

$$\Rightarrow N_i = \kappa \frac{I_i}{L 2\pi r e} \sqrt{\frac{m_i}{2e\Phi}}$$

**Incoming ions density corresponds to a fluid (radial-motion) model except for the  $\kappa$  factor representing angular momentum effects.**

**Thermionic emission follows the Richardson-Dushman law**

$$I_e = C \times L 2\pi R_{\max} \times T_t^2 \exp\left(\frac{W}{kT_t}\right), \quad C \equiv \frac{4\pi m_e k^2}{h^3} \approx 1.202 \times 10^6 \frac{A}{m^2 K^2}$$

**For simplicity in this first analysis, use fluid model even if failing near the probe:**

$$N_e = \frac{I_e}{L 2\pi r e} \sqrt{\frac{m_e}{2e|\Phi_p - \Phi|}}$$

**Poisson equation reads**

$$\frac{1}{r} \frac{d}{dr} r \frac{d\Phi}{dr} = \frac{1}{\varepsilon_0} (N_i e - N_e e) = \frac{1}{L 2\pi r \varepsilon_0} \left[ \frac{\kappa I_i \sqrt{m_i}}{\sqrt{2e|\Phi|}} - \frac{I_e \sqrt{m_e}}{\sqrt{2e|\Phi_p - \Phi|}} \right]$$

**Introducing  $\rho = \ln\left(\frac{r_{sh}}{r}\right)$  and  $\varphi \equiv \frac{\Phi}{\Phi_p}$ , and using  $I_i, I_e$ , it results in**

$$\frac{d^2\varphi}{d\rho^2} = e^{-\rho} j_0 \left[ \frac{1}{\sqrt{\varphi}} - \frac{\mu}{\sqrt{1-\varphi}} \right]$$

$$\mu \equiv \frac{I_e \sqrt{m_e}}{\kappa I_i \sqrt{m_i}} \equiv \frac{\pi}{\kappa} \frac{C T_t^2 e^{-W/kT}}{e N_\infty \sqrt{2e|\Phi_p|/m_e}}$$

$$j_0 \equiv \frac{r_{sh} \kappa I_i \sqrt{m_i}}{L 2\pi \varepsilon_0 |\Phi_p| \sqrt{2e|\Phi_p|}} \equiv \frac{R_{\max}^2}{R_J^2}, \quad R_J^2 \equiv \frac{\pi \sqrt{\sigma_1}}{\kappa} \sqrt{\frac{kT}{e|\Phi_p|}} \frac{\varepsilon_0 |\Phi_p|}{e N_\infty}$$

Both  $\mu$  and  $R_J$  are known for given  $W$ ,  $T_p$ ,  $N_\infty$ ,  $T$ ,  $m_i$ , and a selected bias  $\Phi_p$ . The corresponding value  $R_{\max}$  is unknown, however.

The equation for  $\varphi$  must be integrated for a tentative  $R_{\max}$  under conditions at  $\rho=0$ , i.e.  $r=r_{sh}$ , for matching to two thin layers beyond the sheath (1999 paper).

The value  $R_{\max}$  must allow satisfying condition  $\Phi=\Phi_p$  at  $r=R_{\max}$ .



**Solve for  $\phi$  from  $\frac{d^2\phi}{d\rho^2} = e^{-\rho} \frac{R_{\max}^2}{R_J^2} \left[ \frac{1}{\sqrt{\phi}} - \frac{\mu}{\sqrt{1-\phi}} \right]$ ,  $\phi = \frac{d\phi}{d\rho} = 0$  at  $\rho = 0$ .**

**The condition for  $R_{\max}$  reads  $\phi(\rho_p, \mu, R_{\max}/R_J)=1$ ,  $\rho_p = \ln \sqrt{(e\Phi_p/\sigma_1 kT)}$ .**

**$R_{\max}$  is solved for each  $\Phi_p$ . Decreasing  $|\Phi_p|$ , until that more decreases of it would result in negative derivative at the probe, SCL condition is reached.**

**Results on  $\mu$ ,  $R_{\max}/R_J$  and  $d\phi/d\rho$  at  $\rho_p$ , versus  $\Phi_p$ , are shown for values:**

$$W = 0.75 \text{ eV}, T_p = 300\text{K}, N_{\infty} = 3 \times 10^{11}/\text{m}^3, T = 0.1 \text{ eV, oxygen ion-mass.}$$

**Also shown is  $R_{\max}/\lambda_D$ .**

**Clear effects are: Emission increases the range of radius  $R$  for OML validity; Space-Charge-Limit current (where  $d\phi/d\rho|_{\rho=0}$ ) occurs at very low bias.**

